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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

KARSTEN WIECZOREK  
MANFRED HORSTMANN  
ROLF STEPHAN

Serial No.: 10/621,662

Filed: July 17, 2003

For: METHOD OF REMOVING SIDEWALL  
SPACERS IN THE FABRICATION OF  
A SEMICONDUCTOR DEVICE USING  
AN IMPROVED REMOVAL PROCESS

Examiner: Lan Vinh

Group Art Unit: 1765

Att'y Docket: 2000.104200/DE0108

Customer No.: 23720

**RESPONSE TO OFFICE ACTION DATED MAY 2, 2005**

**Mail Station Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

CERTIFICATE OF MAILING  
37 C.F.R 1.8

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below:

June 22, 2005

Date

*May Paul*  
Signature

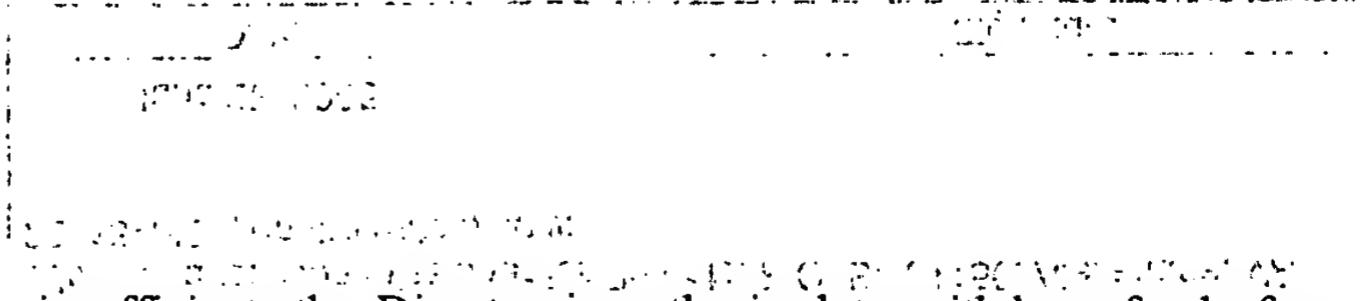
This paper is submitted in response to the Office Action dated May 2, 2005, for which the three-month date for response is August 2, 2005.

No fee is believed to be due in connection with the present paper. However, the Director is authorized to deduct any fees required under 37 C.F.R. §§ 1.16 to 1.21, from Advanced Micro Devices, Inc. Deposit Account No. 01-0365/DE0108.<sup>1</sup>

Reconsideration of the application in view of the following remarks is respectfully requested.

AM

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<sup>1</sup> In the event the monies in that account are insufficient, the Director is authorized to withdraw funds from Williams, Morgan & Amerson, P.C. Deposit Account No. 50-0786/2000.104200.